

Notice of References Cited

Application/Control No.

10/804,722

Applicant(s)/Patent Under
Reexamination
CHOI ET AL.

Examiner

JASON M. MANDEVILLE

Art Unit

2629

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0151694	08-2003	Lee et al.	348/687
*	B	US-6,954,191	10-2005	Hirano et al.	345/77
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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